WHAT IS CLAIMED IS:

	1	1	l.	A sensor array device for detecting an analyte in a fluid, said		
	2	device comprisi	ng:			
	3	an array of sensors; and				
	4	an infrared detector operatively associated with each sensor, wherein said				
	5	infrared detector measures a response in the presence of said analyte.				
	1			The course device according to aloin 1 subspace gold in front		
	1		2. 	The sensor array device according to claim 1, wherein said infrared		
	2	detector is an in	irarea	camera.		
	1	3	3.	The sensor array device according to claim 1, further comprising a		
	2	thermographic i	mage	display.		
E 211						
7	1		1 .	The sensor array device according to claim 1, wherein said detector		
î 7	2	measures a matrix of responses.				
	1	5	5 .	The sensor array device according to claim 4, wherein said matrix		
4 4	2	is 256 x 256.				
4						
6"h 6"h	1		5.	The sensor array device according to claim 1, wherein at least one		
	1 2	of said sensors i	in the	array is a member selected from the group consisting of		
		of said sensors i	in the a	array is a member selected from the group consisting of cting regions sensors, bulk conducting polymer films, surface		
	2	of said sensors i	in the a	array is a member selected from the group consisting of		
	2 3	of said sensors is conducting/non- acoustic wave d	in the a	array is a member selected from the group consisting of cting regions sensors, bulk conducting polymer films, surface		
Hast quest through the tark tark	2 3 4	of said sensors in conducting/none acoustic wave d impregnated po	in the a conduction levices lymeri	array is a member selected from the group consisting of cting regions sensors, bulk conducting polymer films, surface s, fiber optic micromirrors, quartz crystal microbalances, dye		
Haft tark them. He tark tark	2 3 4 5	of said sensors is conducting/none acoustic wave d impregnated po- phthalocyanine polymer sensors	in the accorduction the services sensor sens	array is a member selected from the group consisting of cting regions sensors, bulk conducting polymer films, surface s, fiber optic micromirrors, quartz crystal microbalances, dye ic coatings on optical fibers, sintered metal oxide sensors, rs, Pd-gate MOSFET devices, electrochemical cells, conducting coating sensors, metal FET structures, carbon black-polymer		
tan tan dian dian	2 3 4 5 6	of said sensors is conducting/none acoustic wave d impregnated po- phthalocyanine polymer sensors	in the accorduction the services sensor sens	array is a member selected from the group consisting of cting regions sensors, bulk conducting polymer films, surface s, fiber optic micromirrors, quartz crystal microbalances, dye ic coatings on optical fibers, sintered metal oxide sensors, rs, Pd-gate MOSFET devices, electrochemical cells, conducting		
Hust Hast Street to Sust Street	2 3 4 5 6 7	of said sensors is conducting/none acoustic wave d impregnated po- phthalocyanine polymer sensors composites, mice	in the accorduction the levices lymeric sensor sensor significance levices and the levices are	array is a member selected from the group consisting of cting regions sensors, bulk conducting polymer films, surface s, fiber optic micromirrors, quartz crystal microbalances, dye ic coatings on optical fibers, sintered metal oxide sensors, rs, Pd-gate MOSFET devices, electrochemical cells, conducting coating sensors, metal FET structures, carbon black-polymer		
	2 3 4 5 6 7 8	of said sensors is conducting/none acoustic wave d impregnated po- phthalocyanine polymer sensors composites, mic micro-opto-elec	in the accorduction the sensor sensor s, lipid cro-electro-me	array is a member selected from the group consisting of cting regions sensors, bulk conducting polymer films, surface s, fiber optic micromirrors, quartz crystal microbalances, dye ic coatings on optical fibers, sintered metal oxide sensors, rs, Pd-gate MOSFET devices, electrochemical cells, conducting a coating sensors, metal FET structures, carbon black-polymer extro-mechanical system devices, micromachined cantilevers, and echanical system devices.		
	2 3 4 5 6 7 8 9	of said sensors is conducting/none acoustic wave d impregnated po- phthalocyanine polymer sensors composites, mic micro-opto-elec	in the according to the levices lymeric sensor s, lipid cro-electro-mo	array is a member selected from the group consisting of cting regions sensors, bulk conducting polymer films, surface s, fiber optic micromirrors, quartz crystal microbalances, dye ic coatings on optical fibers, sintered metal oxide sensors, rs, Pd-gate MOSFET devices, electrochemical cells, conducting a coating sensors, metal FET structures, carbon black-polymer extro-mechanical system devices, micromachined cantilevers, and echanical system devices. The sensor array device according to claim 6, wherein at least one		
	2 3 4 5 6 7 8	of said sensors is conducting/none acoustic wave d impregnated po- phthalocyanine polymer sensors composites, mic micro-opto-elec	in the according to the levices lymeric sensor s, lipid cro-electro-mo	array is a member selected from the group consisting of cting regions sensors, bulk conducting polymer films, surface s, fiber optic micromirrors, quartz crystal microbalances, dye ic coatings on optical fibers, sintered metal oxide sensors, rs, Pd-gate MOSFET devices, electrochemical cells, conducting a coating sensors, metal FET structures, carbon black-polymer extro-mechanical system devices, micromachined cantilevers, and echanical system devices.		
that the the the that the	2 3 4 5 6 7 8 9	of said sensors is conducting/none acoustic wave d impregnated po- phthalocyanine polymer sensors composites, mic micro-opto-elec- of said sensors is	in the according to the levices lymeric sensor s, lipid cro-electro-mo	array is a member selected from the group consisting of cting regions sensors, bulk conducting polymer films, surface s, fiber optic micromirrors, quartz crystal microbalances, dye ic coatings on optical fibers, sintered metal oxide sensors, rs, Pd-gate MOSFET devices, electrochemical cells, conducting a coating sensors, metal FET structures, carbon black-polymer extro-mechanical system devices, micromachined cantilevers, and echanical system devices. The sensor array device according to claim 6, wherein at least one		
	2 3 4 5 6 7 8 9	of said sensors is conducting/none acoustic wave dimpregnated por phthalocyanine polymer sensors composites, micro-opto-electron of said sensors is	in the according to the conduction the according to the conduction the according to the conduction the according to the accor	array is a member selected from the group consisting of cting regions sensors, bulk conducting polymer films, surface s, fiber optic micromirrors, quartz crystal microbalances, dye ic coatings on optical fibers, sintered metal oxide sensors, rs, Pd-gate MOSFET devices, electrochemical cells, conducting a coating sensors, metal FET structures, carbon black-polymer extro-mechanical system devices, micromachined cantilevers, and echanical system devices. The sensor array device according to claim 6, wherein at least one array is a conducting/nonconducting regions sensor.		

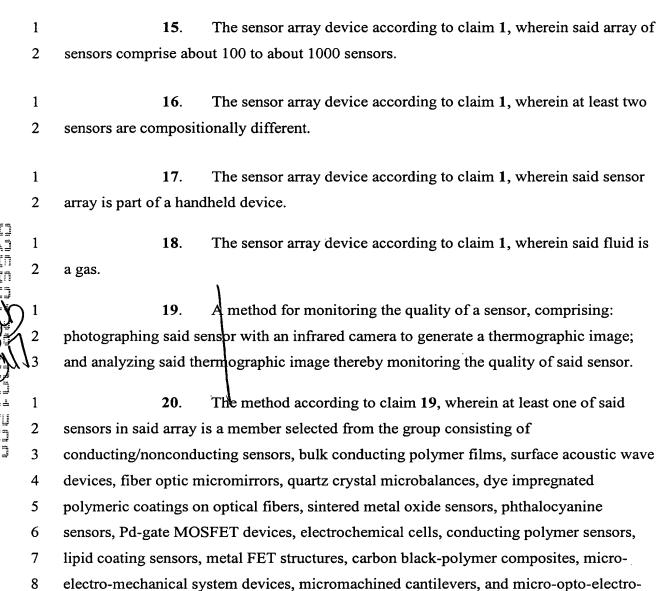
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9.	The sensor array device according to claim 8, wherein said
comparison algorithm i	s performed using a pattern recognition algorithm which is a
member selected from	the group consisting of principal component analysis, Fisher linear
discriminant analysis, s	oft independent modeling of class analogy, K-nearest neighbors,
and canonical discrimin	nant analysis.

- 10. The sensor array device according to claim 1, wherein said analyte is a member selected from the group consisting of alkanes, alkenes, alkynes, dienes, alicyclic hydrocarbons, arenes, alcohols, ethers, ketones, aldehydes, carbonyls, carbanions, polynuclear aromatics, heterocycles, organic derivatives, biomolecules, microorganisms, fungi, bacteria, microbes, viruses, metabolites, sugars, isoprenes and isoprenoids, fatty acids and their derivatives.
- 11. The sensor array device according with claim 1, wherein said analyte is a microorganism marker gas.
- array is used in an application selected from the group consisting of environmental toxicology, remediation, biomedicine, material quality control, food monitoring, agricultural monitoring, heavy industrial manufacturing, ambient air monitoring, worker protection, emissions control, product quality testing, oil/gas petrochemical applications, combustible gas detection, H₂S monitoring, hazardous leak detection, emergency response and law enforcement applications, explosives detection, utility and power applications, food/beverage/agriculture applications, freshness detection, fruit ripening control, fermentation process monitoring and control, flavor composition and identification, product quality and identification, refrigerant and fumigant detection, cosmetic/perfume applications, fragrance formulation, chemical/plastics/pharmaceuticals applications, fugitive emission identification, solvent recovery effectiveness, hospital/medical applications, anesthesia and sterilization gas detection, infectious disease detection, breath analysis and body fluids analysis.

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13. The sensor array device array according to claim 1, further comprising robotic armature for high throughput assay screening.



sensors in said array is a conducting/nonconducting regions sensor.

comprising: photographing the sensor with an infrared camera to generate a

The sensor array device according to claim 1, wherein said array of

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mechanical system devices.

21.

22.

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14.

sensors comprise about 10 to about 100 sensors.

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The method according to claim 20, wherein at least one of said

A method for identifying the conducting path of a sensor,



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thermographic image; and analyzing the thermographic image to identify the conducting path of said sensor.

23. The method according to claim 22, wherein said sensor is a					
member selected from the group consisting of conducting/nonconducting regions sensor	rs,				
bulk conducting polymer films, surface acoustic wave devices, fiber optic micromir					
quartz crystal microbalances, dye impregnated polymeric coatings on optical fibers,					
sintered metal oxide sensors, phthalocyanine sensors, Pd-gate MOSFET devices,					
electrochemical cells, conducting polymer sensors, lipid coating sensors, metal FET					
structures, carbon black-polymer composites, micro-electro-mechanical system devices	'>				
micromachined cantilevers, and micro-opto-electro-mechanical system devices.					

infrared detector output having a plurality of pixels, said computer program product comprising:

code for finding the temperature at each pixel of said output;

code for sorting said plurality pixels of said output based on temperature;

code for calculating the cumulative sum of temperature and plotting the cumulative sum against the ratio of said plurality of pixels;

code for calculating the ratio of pixels that generates the 50% cumulative sum of temperature; and

A computer program product to calculate the uniformity of a

25. The computer code product according to claim 24, wherein said infrared detector output is a thermograph.

a computer readable storage medium for holding said codes.